The Department of Comments of the National Natio						Application No.: 10/042,673			
U.S. Department of Commerce, Patent and Trademark Office						Filing date: January 8, 2002			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Inventors: Xiaozhong Dang et al.				
OIPE					Group Art Unit: 2823				
METHOD OF MAKING TRANSDUCER WITH INORGANIC NONFERROMAGNETIC APEX REGION					Examiner name: Khiem D. Nguyen				
DCT 3 1 2003	Y)				Attorney	Docket No.	RR-1765		
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EXAMINER: 509; Draw	Initialization	al if reference	n if not in com	whether or not cita nformance and not c	tion is in	conformance Include co	with MPER	?	